

2878



862.3157

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

4/I.D.S.  
G. Stenly

In re Application of: )  
MASAHIKO OKUNUKI ) : Examiner: Not Yet Assigned 6-12-00  
Application No.: 09/457,083 ) : Group Art Unit: 2878  
Filed: December 7, 1999 ) :  
For: ELECTRON BEAM ) :  
ILLUMINATION APPARATUS, ) :  
ELECTRON BEAM EXPOSURE ) :  
APPARATUS, AND DEVICE ) :  
MANUFACTURING METHOD ) : Date: June 6, 2000

Assistant Commissioner for Patents  
Washington, D.C. 20231

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

Sir:

In compliance with the duty of disclosure under  
37 C.F.R. § 1.56 and in accordance with the practice under  
37 C.F.R. §§ 1.97 and 1.98, the Examiner's attention is  
directed to the document listed on the enclosed Form  
PTO-1449. A copy of the listed document is also enclosed.

RECEIVED  
JUN 12 2000  
TC 2000 06 12 00M

The Examiner's attention is also directed to the following U.S. Application:

<u>APPLICATION NO.</u>	<u>FILING DATE</u>	<u>GROUP ART UNIT.</u>
09/060,354	April 15, 1998	2778

In accordance with 37 C.F.R. § 1.98(a)(2)(iii), no copy of the cited U.S. Application is enclosed.

CONCLUSION

It is respectfully requested that the above information be considered by the Examiner and that a copy of the enclosed Form PTO-1449 be initialled and returned indicating that such information has been considered.

Applicant's undersigned attorney may be reached in our New York office by telephone at (212) 218-2100. All correspondence should be directed to our new address given below.

Respectfully submitted,

  
\_\_\_\_\_  
Attorney for Applicant

Registration No. 42476

FITZPATRICK, CELLA, HARPER & SCINTO  
30 Rockefeller Plaza  
New York, New York 10112-3801  
Facsimile: (212) 218-2200

81526v1/jlc